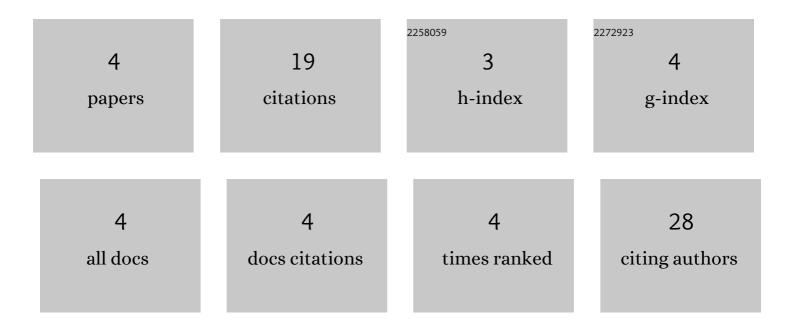
## Lei Sun

## List of Publications by Year in descending order

Source: https://exaly.com/author-pdf/1011024/publications.pdf Version: 2024-02-01



LEI SUM

#	Article	IF	CITATIONS
1	Influence of sputtering power on properties of ZnO thin films fabricated by RF sputtering in room temperature. Science China Information Sciences, 2012, 55, 951-955.	4.3	11
2	Fabrication and characteristics of ZnO thin films deposited by RF sputtering on plastic substrates for flexible display. Science China Information Sciences, 2012, 55, 1441-1445.	4.3	4
3	Fabrication and characteristics of ZnO MOS capacitors with high-K HfO2 gate dielectrics. Science China Technological Sciences, 2010, 53, 2333-2336.	4.0	3
4	Comparative surfacing studies of sputtered and thermal annealed ZnO films wet etched with NH 4 Cl and acidic etchants. Surface and Coatings Technology, 2017, 331, 85-89.	4.8	1